



Attorney's Docket No. 5649-917

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re: Chung et al. Confirmation No.: 6119  
Serial No.: 10/043,027 Group Art Unit: 2813  
Filed: January 9, 2002 Examiner: William C. Vesperman  
For: METHODS OF FORMING AN INTEGRATED CIRCUIT CAPACITOR IN WHICH  
A METAL PREPROCESSED LAYER IS FORMED ON AN ELECTRODE  
THEREOF

Date: June 18, 2004

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER ALLOWANCE (37 C.F.R. 1.312)**

Sir:

Applicants provide the present Amendment responsive to the Notice of Allowance" of March 26, 2004. Applicants provide the present Amendment pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.